

NANOTS2016 Time Table

9 (Wed)	AM	Life Hall (5F)	Process Evaluation Techniques: Metrology and Inspection 9:15-10:35		Authors Corner 10:35-10:55	Tutorial: Trend in Electron Microscopy 10:55-12:35		Break (FEI Luncheon Seminar) 12:35-13:55	
		Senri Room (6F)							
	PM	Life Hall (5F)	Invited Talk 13:55-14:55			Power Device Analysis I 15:15-16:30		Power Device Analysis II 16:50-18:05	
		Senri Room (6F)		Break 14:55-15:15			Authors Corner 16:30-16:50		Authors Corner 18:05-18:25

10 (Thu)	AM	Life Hall (5F)	Electron Optics & Applications 9:00-10:15			Commercial Session 10:35-12:03		Present: Poster Short Photo Group	Break (Hamamatsu Photonics Luncheon Seminar) 12:30-13:50	
		Senri Room (6F)			Authors Corner 10:15-10:35	Exhibition 10:00-				
	PM	Life Hall (5F)	Invited Talk 13:50-14:50			Fault Localization I 16:10-17:00		Special Invited Talk 17:20-18:20		Evening Session 18:50-20:50 At Senri Hankyu Hotel
		Senri Room (6F)		Break 14:50-15:10		Poster Session 15:10-16:10		Exhibition -17:00		

11 (Fri)	AM	Life Hall (5F)	Tutorial 9:00-9:50			Fault Localization II 10:10-11:25				
		Senri Room (6F)			Break 9:50-10:10	Exhibition 10:00-		Authors Corner 11:25-11:45	Break 11:45-12:45	
	PM	Life Hall (5F)	Fault Localization III 12:45-14:00			Physical Analysis I 14:20-15:35		Physical Analysis I 15:55-17:35		
		Senri Room (6F)			Authors Corner 14:00-14:20	Exhibition -17:00		Authors Corner 15:35-15:55		Authors Corner 17:35-17:55